

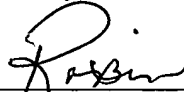


IFIN

PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 10, 2006.


Signature

Appl No. : 10/625,316
Applicant : Sriram Venkatasanthanam, et al.
Filed : July 23, 2003
Title : METHOD FOR FORMING INHERENTLY
INK-RECEPTIVE FILM SUBSTRATES

Confirmation No. 7750

TC/A.U. : 1732
Examiner : Mark Eashoo

Docket No. : 50770/A23
Customer No. : 23363

RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
November 10, 2006

Commissioner:

This is in response to the Office action dated July 10, 2006. Claims 1-5 are pending in the application. Claims 1-4 stand rejected under 35 U.S.C. § 103(a) as being unpatentable over Freedman (US 4,713,273) in view of Yamamoto et al. (US 3,551,538). It appears that claim 5 is also rejected based on the same combination. For the reasons that follow, Applicants respectfully traverse the rejection and request reconsideration.

The Examiner states that "Freedman teaches the basic claimed process of forming an ink receptive substrate comprising: forming a melt processable base layer from a water insoluble thermoplastic polymer (9:65-10:45) and Fig. 6); and coextruding a bas[e] layer and skin or ink receptive layer (9:20-11:10)." The Examiner acknowledges that Freedman does not teach an ink receptive layer formed from a polyolefin and polyethylene oxide.